

Application/Control No.	Applicant(s)/Patent under Reexamination
10/574,687	MORITA ET AL.
Examiner	Art Unit
TAEYOON KIM	1651

	SEARCHED					
Class	Subclass	Date	Examiner			

INTERFERENCE SEARCHED					
Subclass	Date	Examiner			

SEARCH N (INCLUDING SEARC	IOTES CH STRATEGY	)
	DATE	EXMR
updated search	12/24/2008	тк